



Dkt. 50888-XA CCD

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants : Yukio IDE et al.

Serial No. : 10/672,353

Group Art Unit 1742

Filed : September 25, 2003

Examiner M.P. Alexander

For : METHOD OF PRODUCING
A SPUTTERING TARGET

REPLY UNDER 37 C.F.R. §1.111

1185 Avenue of the Americas
New York, NY 10036
March 6, 2007

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

S I R:

In response to the Office Action dated September 6, 2006, applicants respectfully request reconsideration and further examination of the above-identified application for the reasons set forth below.

Attachments

Attention is respectfully directed to the following submissions, all of which are attached hereto:

1. A Facsimile copy of a Declaration of Yukio Ide, one of the joint applicants herein, under 37 C.F.R. §1.132. This Declaration was prepared for execution by all eight of the joint applicants herein, but as applicants' undersigned attorney is informed and